Docket No.: 02008/092002 (PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Takahiro Yamaguchi et al.

Application No.: 10/776,926 Confirmation No.: 2381

Filed: February 11, 2004 Art Unit: 2611

For: MEASURING APPARATUS AND Examiner: E. Bayard MEASURING METHOD

## REPLY UNDER 37 CFR § 1.111

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Madam:

In response to the Office Action dated April 3, 2009, please reconsider this application in view of the following.